

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
:
Shuji HIRAO :
:
Serial No.: : Group Art Unit:
:
Filed: July 23, 2003 : Examiner:
:
For: METHOD AND APPARATUS FOR PLATING SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of Japanese Patent Laid-Open Publication No. 2001-316869 is discussed in the present specification.

Serial No.:

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Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. 60188-594	SERIAL NO.			
			APPLICANT Shuji HIRAO				
			FILING DATE July 23, 2003	GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US					
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						Yes	No
		JP P2001-316869A	11/16/2001	TOKYO ELECTRON LTD		Japan (w/ English Abstract)	
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.